

<b>Notice of References Cited</b>	Application/Control No. 10/707,248	Applicant(s)/Patent Under Reexamination RIVARA, MARIA CECILIA	
	Examiner Herng-der Day	Art Unit 2128	Page 1 of 1

U.S. PATENT DOCUMENTS					
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS						
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NON-PATENT DOCUMENTS		
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Jones et al., "Adaptive Refinement of Unstructured Finite-Element Meshes", Finite Elements in Analysis and Design, Volume 25, Issues 1-2, March 1997, pages 41-60.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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